

BEAMeeting C2N-CNRS Palaiseau / Paris 2024

Wednesday, May 15th, 2024

Training Jing Becker / Jörg Günther	Session 1: BEAMER – Layout Operation and Fracturing	9:00
	Coffee Break	10:30
Training Jörg Günther / Jing Becker	Session 2: Proximity Correction Overview (continues 15:30)	10:45
	Lunch Break	12:00
Nezih Ünal GenISys & Edmond Cambriil C2N CNRS	Welcome & round the room introduction of attendees	13:00
Nezih Ünal GenISys	GenISys Update	13:20
Jörg Günther GenISys	BEAMER Update – What's new?	13:40
Jean René Coudeville C2N CNRS	Greyscale e-beam lithography and its transfer into silicon structure	14:00
	Coffee Break (visit of "International Day of Light" poster session possible, www.lightday.org)	14:30
Nezih Ünal GenISys	Advanced PEC Features & Settings	15:30
	User questions and Application cases, BMR demo e.g. fields or fracturing	16:00
Sven Bauerdick GenISys	SEM metrology automation with ProSEM and InSPEC	16:30
	Closing (CNRS C2N tour possible on request)	17:00
Thursday, May 16th, 2024		
Jing Becker GenISys	Loops, Variables, Functions	9:00
Jörg Günther GenISys	BEAMER strategies to improve pattern fidelity on MLA laser writer	9:30
	Open Discussion and User Workshops – Bring your BEAMER questions	10:00
	Application cases, e.g. BMR fields module	
	Coffee Break	10:30
Sven Bauerdick GenISys	Insights into ProSEM: Contours, metrology, batch, and layout	11:00
Nezih Unal / Jörg Günther / Sven Bauerdick, GenISys	Discussion & feedback BEAMER/ProSEM - Feature Wishes	11:45
	Closing	13:00